


Applicant	:	Shigeki SAKAI, et al.
Serial No.	:	10/090,851
Filed	:	March 4, 2002
For	:	SEMICONDUCTOR NONVOLATILE STORAGE ELEMENT AND METHOD OF FABRICATING THE SAME
Group Art Unit	:	(Not yet known)
Examiner	:	(Not yet known)

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to ASSISTANT COMMISSIONER FOR PATENTS, WASHINGTON, DC 20231 on April 10, 2002.

 04/10/02
(Signature and Date)

Assistant Commissioner
for Patents
Washington, D.C. 20231

Sir:

Attached hereto is a copy of Form PTO-1449 together with copies of the one reference listed therein.

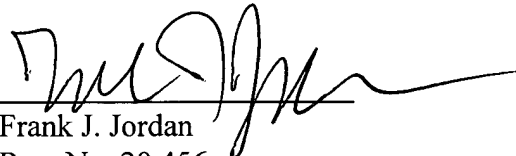
F-7337

Serial No. 10/090,851

This Information Disclosure Statement is being filed prior to issuance of the first Official Action. Therefore, there is no charge for filing this IDS.

Respectfully submitted,

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